# Monthly LabAdviser update: 25/10 2013

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| Updated Subject  | Contributor | Link to the updated pages |
| AOE etching of fused silica (quartz) | **Joachim Johansen @ nanotech** | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Etching_of_Bulk_Glass/AOE_etching_of_fused_silica#Joachim_Thomsen_.28student_at_Nanotech.29_October_2013> |
| AOE etching of nitride-Added etch uniformity info to the nitride etch | **Eric Jensen @nanotech** | [http://labadviser.danchip.dtu.dk/index.php/Specific\_Process\_Knowledge/Etch/AOE\_(Advanced\_Oxide\_Etch)/Silicon\_Nitride\_Etch\_using\_AOE](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/AOE_%28Advanced_Oxide_Etch%29/Silicon_Nitride_Etch_using_AOE) |
| Feedback links to all pages in LabAdviserMakes it easy for the LabAdviser users to give feedback to a specific page in LabAdviser (please do not hesitate to use it). | **Danchip** |  |
| Furnace phosphor pre dep.Dope with phosphorous | Mikkel D. Marr @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thermal_Process/Dope_with_Phosphorus#Results> |
| IBE Gold etch/sputteringZep500A mask vs. Ti mask | **Berit G. Herstrøm @danchip** | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/IBE%E2%81%84IBSD_Ionfab_300/IBE_Au_etch#IBE_Au_etch_with_Ti_mask> |